



Appl. No. 09/905,286

#13/B  
Fuller  
8/13/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/905,286  
Filing Date ..... July 13, 2001  
Inventor..... Cem Basceri et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1762  
Examiner ..... Fuller, Eric B.  
Attorney's Docket No. .... MI22-1724  
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate  
Comprising Dielectric Layers

**RESPONSE TO APRIL 30, 2002 FINAL OFFICE ACTION TO ACCOMPANY RCE FILING**

To: Box RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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**AMENDMENTS**

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TC 1700

**In the Claims**

Please replace the indicated claims with the following clean versions of the claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any indicated claim. A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.